



REPLY UNDER 37 C.F.R. 1.116 – EXPEDITED PROCEDURE
TECHNOLOGY CENTER 1762

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit : 1762 Customer No.: 035811
Examiner : James Lin
Serial No. : 10/055,770
Filed : January 23, 2002
Inventors : Shigeo Fujimori Docket No.: 1023-02
: Yoshiyuki Kitamura Confirmation No.: 8726
: Hiromitsu Kanamori
: Takeshi Ikeda
: Tetsuo Oka
Title : INTEGRATED MASK AND METHOD AND
: APPARATUS FOR MANUFACTURING
: ORGANIC EL DEVICE USING THE SAME Dated: May 31, 2007

Mail Stop AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Certificate of Mailing Under 37 CFR 1.8

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Claim of Extension of Time for Response, in duplicate

Reply Under 37 C.F.R. 1.116

Comparison Chart (5 sheets)

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Name of Applicant, Assignee, Applicant's Attorney
or Registered Representative:

DLA Piper US LLP

Customer No. 35811

By: Nancy Niñez

Date: 5/31/07